RESPONSE UNDER 37 C.F.R. § 1.116 **EXPEDITING PROCEDURE EXAMINING GROUP 2800**

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Buerke, et al.

Docket No.:

INF-118

Serial No.:

10/724,136

Art Unit:

2811

Date Filed:

December 1, 2003

TITLE:

Low Resistance Barrier For A Microelectronic Component And Method For

Fabricating The Same

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to Mail Stop AF at the U.S. Patent and Trademark Office at (571) 273-8300 on August 25, 2005:

- Certification of Facsimile Transmission (1 page)
- Amendment (5 pages)

Respectfully submitted,

ristiz Engeldal-C

Kristy Engeldahl Legal Assistant

Confirmation Respectfully Requested

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For:

Low Resistance Barrier For A Microelectronic Component And Method For

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Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Final Office Action mailed June 30, 2005. Please amend the above-referenced application as follows.